

Compound Semiconductor Wafer Handling

High Performance GaAs, GaN, SiC, Sapphire and InP Wafer Handling Products



AVT - Automatic
Vertical Wafer
Transfer



LCT - Automatic
Low Contact
Wafer Transfer



AET - Automatic
Wafer Aligner and
Escalator



AWT - Automatic
Wafer Horizontal
Transfer



FWCR2 - Freedom
Wand Cordless
Vacuum Wand

FWTTA1 -
Freedom Table
Top Vacuum Wand



EZ Guide Automatic
and Manual Notch and
Flat Aligners



Silicon vs. Compound Substrates
T693PKAS3-001 / T79xPKAS series
PEEK Vacuum Wand Tips

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